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INFORMATION DISCLOSURE STATEMENT

Applicants: Takeshi FUKADA et al.

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OTHER DOCUMENT

(Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner
InitialInventor: Yasuhiko TAKEMURA, "Process for Fabricating Semiconductor Device" Filing Date: October 26, 2001,
Specifications and Drawings for US Application Serial No. 09/983,882COPY OF PAPERS
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1-12-03

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